## 23390

# IN THE U.S. PATENT AND TRADEMARK OFFICE

Inventor Hilde HARDTDEGEN et al

Patent App. 10/550,365

Filed 14 June 2006 Conf. No. 7978

For METHOD FOR DEPOSITING COMPOUNDS ON A SUBSTRATE

BY MEANS...

Art Unit 1792 Examiner Smith, F

Hon. Commissioner of Patents

Box 1450

Alexandria, VA 22313-1450

#### FOURTH AMENDMENT

In response to the Office Action mailed 11 June 2008, please amend the above-identified application as follows:

## TITLE AMENDMENT

Please rewrite the title as follows:

-- MOCVD GAS-PHASE DEPOSITION APPARATUS

## DRAWING AMENDMENT

Please replace any drawing on file with te hereto attached Replacement Drawing (5 sheets).

- **1** - 23390AM4.WPD